

JUL 29 2005

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Walter SCHWARZENBACH et al. Confirmation No. 9739
Application No.: 10/733,729 Group Art Unit: 2812
Filing Date: December 12, 2003 Examiner: D. Nhu
For: METHOD OF MAKING CAVITIES IN A Atty. Docket No.: 4717-9200
SEMICONDUCTOR WAFER

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication responds to the Office Action dated April 28, 2005, concerning the above-identified application.

Amendments to the Specification appear on page 2.

Amendments to the Drawings appear on page 3.

Amendments to the claims begin on page 4.

Remarks begin on page 8 of this paper.

No fee is believed due with this Amendment. Please charge any fee deemed necessary to Winston & Strawn LLP Deposit Account No. 50-1814.